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Our Case No. 9281-4017

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hitoshi Seki et al.

Serial No. 09/595,415

Filing Date: June 16, 2000

For: ETCHING REAGENT, AND METHOD
FOR MANUFACTURING ELECTRONIC
DEVICE SUBSTRATE AND
ELECTRONIC DEVICE

)
)
) Examiner:
) Shamim Ahmed
)
)
) Group Art Unit:
) 1765
)

AMENDMENT AND RESPONSE UNDER 37 C.F.R. § 1.116

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P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action dated December 9, 2004, in the above-referenced application, please reconsider the rejection in view of the amendment and remarks presented herein.

The Applicants believe entry of the accompanying amendment will place their application in condition for allowance. Accordingly, please amend the application as follows.

Applicants' amendments to the claims begin at page 2 of this paper.

The Applicants' remarks begin at page 5 of this paper.